

NATIONAL INSTITUTE FOR FUSION SCIENCE

Calculation of Hydrogen Outgassing Rate of LHD by Recombination Limited Model

K. Akaishi and M. Nakasuga

(Received - Mar. 28, 2002)

NIFS-728

Apr. 2002

This report was prepared as a preprint of work performed as a collaboration research of the National Institute for Fusion Science (NIFS) of Japan. The views presented here are solely those of the authors. This document is intended for information only and for future publication in a journal after some rearrangements of its contents.

Inquiries about copyright and reproduction should be addressed to the Research Information Center, National Institute for Fusion Science, Oroshi-cho, Toki-shi, Gifu-ken 509-5292 Japan.

RESEARCH REPORT
NIFS Series

Calculation of Hydrogen Outgassing Rate of LHD by Recombination Limited Model

K. Akaishi and M. Nakasuga*

National Institute for Fusion Science

**Graduate School of Energy Science, Kyoto University*

Abstract

To simulate hydrogen outgassing in the plasma vacuum vessel of LHD, the recombination limited model is presented, where the time evolution of hydrogen concentration in the wall of the plasma vacuum vessel is described by a one-dimensional diffusion equation. The hydrogen outgassing rates when the plasma vacuum vessel is pumped down at room temperature and baked at 100 °C are calculated as a function of pumping time. The calculation shows that the hydrogen outgassing rate of the plasma vacuum vessel can be reduced at least by one order of magnitude due to pumping and baking. This prediction is consistent with the recent result of outgassing reduction observed in the pumping-down and baking of the plasma vacuum vessel in LHD.

Keywords: stainless steel chamber, hydrogen outgassing rate, bakeout, recombination limited model

1. Introduction

Recently it has been proposed by Moore [1] that hydrogen outgassing in stainless steel vacuum chamber should be described by the recombination limited model (RLM) rather than the diffusion limited model (DLM). However, it has not been reported so far how to calculate concretely the recombination limited outgassing rate in a vacuum chamber. Then we have developed a model to calculate the hydrogen outgassing rate of a stainless steel chamber with RLM [2]. The calculation model is applied to simulate hydrogen outgassing rates of the plasma vacuum vessel of LHD fabricated of 316 stainless steel in the procedures of pumping-down at room temperature and subsequent baking at 100 °C.

2. Recombination limited model

The hydrogen desorption from the wall of a stainless steel chamber can be described with a one-dimensional diffusion equation. The equation is

$$\frac{\partial u}{\partial t} = D \frac{\partial^2 u}{\partial x^2}, \quad (1)$$

where $u(x,t)$ and D are the hydrogen concentration and bulk diffusion coefficient for hydrogen in the wall of the stainless steel chamber, respectively. Equation (1) is solved for the vacuum chamber wall of unit cross section and thickness d . The initial concentration in the vacuum chamber wall is u_0 and is constant throughout the wall. At time $t = 0$ vacuum is applied to one surface of the wall (where $x = 0$) and atmosphere to the other surface of the wall (where $x = d$). The initial condition is

$$u(x,t) = u_0 \text{ for } 0 \leq x \leq d \text{ at } t = 0. \quad (2)$$

The boundary conditions are

$$2K_r u^2 = D \frac{\partial u}{\partial x} \text{ for } x = 0 \text{ at } t \geq 0 \quad (3)$$

and

$$\frac{\partial u}{\partial x} = 0 \text{ for } x = d \text{ at } t \geq 0, \quad (4)$$

where K_r is the molecular recombination rate constant of hydrogen atom at the wall surface of the stainless steel chamber. The condition (4) shows that hydrogen atoms diffusing in the solid wall are reflected inside the wall at the plane of $x = d$. From the condition (3) the hydrogen outgassing rate q (H_2 molecules $\cdot \text{cm}^{-2} \text{s}^{-1}$) is given by

$$q(t) = K_r u^2 = \frac{D}{2} \left(\frac{\partial u}{\partial x} \right) \text{ for } x = 0 \text{ at } t \geq 0. \quad (5)$$

In the condition (3) the readsorption of hydrogen molecules in the gas phase to the wall surface of the vacuum chamber is not considered, since the sticking probability of hydrogen molecule at the wall surface is negligibly small. In the condition (4) the permeation of atmospheric hydrogen through the wall is not taken into account, since the solubility of atmospheric hydrogen to the wall of stainless steel is negligibly small compared to the initial hydrogen concentration in the wall and the hydrogen pressure in the atmosphere is as low as 10^{-4} Torr.

3. Calculation of hydrogen outgassing rate

Since the boundary condition (3) expresses mathematically a non-linear

relation, it is difficult to solve analytically the diffusion equation. So we solve numerically the equation (1) using the finite element method. Using the data of diffusion and recombination coefficients of hydrogen measured experimentally for austenitic stainless steels, Langley [3] has expressed these coefficients as a function of temperature with the following empirical formulas; the coefficient in the bulk diffusion D is

$$D = 3.64 \times 10^{-2} e^{-\frac{E_b}{RT}} \text{ cm}^2\text{s}^{-1}, \quad (6)$$

where E_b is the activation energy of bulk diffusion and $E_b = 60 \text{ kJ} \cdot \text{mol}^{-1}$, R is the gas constant ($R = 8.314 \text{ J} \cdot \text{mol}^{-1}\text{K}^{-1}$) and T is the absolute temperature, and the recombination coefficient K_r is

$$K_r = 3.90 \times 10^{-16} e^{-\frac{E_r}{RT}} \text{ cm}^4\text{s}^{-1}, \quad (7)$$

where E_r is the activation energy for molecular recombination and $E_r = 70 \text{ kJ} \cdot \text{mol}^{-1}$. The hydrogen outgassing rates of the plasma vacuum vessel in LHD are calculated for the following pumping procedures; (1) the plasma vacuum vessel is pumped down at room temperature for 2 days, and (2) subsequently the plasma vacuum vessel is baked at $100 \text{ }^\circ\text{C}$ (373 K) for 5 days, and (3) after the baking the plasma vacuum vessel is again pumped down at room temperature for 2 days. Temperatures of the plasma vacuum vessel in the start and end of baking are changed equally at the rate of 7.3 K/h . Since Nemanic et al., [4] have recently measured the hydrogen content in the 304 stainless steel sample by the thermal extraction method and reported that the hydrogen content is as high as $9 \times 10^{19} \text{ H atoms} \cdot \text{cm}^{-3}$, the initial hydrogen concentration in the wall of the plasma vacuum vessel is assumed at $u_0 = 1 \times 10^{20} \text{ H atoms} \cdot \text{cm}^{-3}$. The wall thickness d is taken as $d = 15 \text{ mm}$ which is the same as that of the plasma vacuum vessel in LHD. Figures 1 shows the surface concentration $u(0, t)$ and the outgassing rate $2q$ ($= D\partial u/\partial x$) calculated as a function of pumping time for the plasma vacuum vessel. Figure 2 shows the hydrogen concentration $u(x, t)$ calculated as a function of position x in the wall of the plasma vacuum vessel at different pumping times.

4. Discussion and summary

From Fig. 1 we can see that by the pumping-down at room temperature for 2 days without baking, the surface hydrogen concentration of the plasma vacuum vessel is reduced by about one order of magnitude from $u_0 = 10^{20}$ to

$u(0,t) \cong 1.4 \times 10^{19} \text{ H} \cdot \text{cm}^{-3}$ and as a result, the outgassing rate is reduced to $q \cong 5.0 \times 10^{10} \text{ H}_2 \cdot \text{cm}^{-2} \text{s}^{-1}$, which value is equivalent to about $1.4 \times 10^{-9} \text{ Torr } \ell \cdot \text{cm}^{-2} \text{s}^{-1}$. In the recent operation of LHD, it has been observed that the ultimate pressure of hydrogen in the plasma vacuum vessel after pumping down at room temperature for 5 days reaches about $2 \times 10^{-6} \text{ Pa}$ ($\cong 1.5 \times 10^{-8} \text{ Torr}$). The hydrogen outgassing rate measured in the plasma vacuum vessel q_{exp} can be expressed as

$$q_{\text{exp}} = S_{\text{H}_2} P_{\text{H}_2} / A, \quad (8)$$

where A is the surface area of the plasma vacuum vessel, P_{H_2} is the hydrogen pressure, S_{H_2} is the pumping speed for hydrogen. Since the nominal pumping speed provided with the pumping system in LHD is expressed with the pumping speed for nitrogen S_{N_2} , using the root of mass ratio of hydrogen and nitrogen molecules ($\sqrt{m_{\text{N}_2} / m_{\text{H}_2}} \cong 3.7$) we can estimate the pumping speed for hydrogen as follows;

$$S_{\text{H}_2} = \sqrt{m_{\text{N}_2} / m_{\text{H}_2}} S_{\text{N}_2}.$$

Then, by substituting $S_{\text{N}_2} = 1 \times 10^4 \ell \cdot \text{s}^{-1}$, $A = 5 \times 10^6 \text{ cm}^2$ and the ultimate pressure of hydrogen $P_{\text{H}_2} = 1.5 \times 10^{-8} \text{ Torr}$ into the equation (8), the experimental outgassing rate of hydrogen for the plasma vacuum vessel is estimated at $q_{\text{exp}} \cong 1.2 \times 10^{-10} \text{ Torr } \ell \cdot \text{cm}^{-2} \text{s}^{-1}$. If we accept this experimental outgassing rate as a reasonable one for the plasma vacuum vessel, we can conclude that the calculation with RLM estimates the outgassing rate for the plasma vacuum vessel one order of magnitude larger than the experimental one. To improve the accuracy in the calculation of outgassing rate, we need to select properly numerical values for the recombination coefficient and initial hydrogen concentration. Pick and Sonnenberg [5] have discussed that the variation of recombination coefficient varies in orders of magnitude with contamination of the surface of solid wall. It is reported by Nemanic et al., [4] that the initial concentration of hydrogen in stainless steel as raw material distributes in the range $1.6 \times 10^{19} \leq u_0 \leq 10^{20} \text{ H} \cdot \text{cm}^{-3}$. Therefore we are allowable to select suitably values of K_r and u_0 for fitting the calculated outgassing rate to the experimental one. From the recent study [2] for the dependence of recombination coefficient on outgassing rate, following set of values $K_r \cong 10^{-27} \text{ cm}^4 \text{s}^{-1}$ at 300 K and $u_0 \cong 3 \times 10^{19} \text{ H} \cdot \text{cm}^{-3}$ are recommended to simulate the outgassing rate in the plasma vacuum vessel. Fig. 1(b) shows that by the baking at 100 °C for 5 days for the

plasma vacuum vessel, the hydrogen outgassing rate is reduced by one order of magnitude from $q = 5 \times 10^{10}$ to $3.5 \times 10^9 \text{ H}_2 \cdot \text{cm}^{-2}\text{s}^{-1}$ (at $t = 200\text{h}$). On the other hand, when the plasma vacuum vessel in LHD was baked at 100°C for 6 days, it has been observed that the hydrogen pressure is reduced by about one order of magnitude from 1.5×10^{-6} to $2.5 \times 10^{-7} \text{ Pa}$. Thus one can say that the calculation predicts well the effect of baking at 100°C for the reduction of outgassing rate. In Fig. 1(a) it is shown that the surface hydrogen concentration $u(0, t)$ at the end of baking starts to increase from pumping time of $t = 180 \text{ h}$. The increase may be explained as the accumulation of diffusing hydrogen at the wall surface, since the desorption rate of hydrogen from the wall surface is limited to low due to the rapid decrease of recombination coefficient with decrease of wall temperature. Fig. 2 shows that the hydrogen concentration in the range from $x = 0.024$ to 1.5 cm in the wall remains unchanged by the baking at 100°C . The vacant range of hydrogen in the near surface of the wall can be considered with the diffusion length x_D , which is given as $x_D \cong \sqrt{\pi Dt}$. For the baking time $t = 5$ days ($= 4.32 \times 10^5 \text{ s}$) and the diffusion coefficient $D = 1.44 \times 10^{-10} \text{ cm}^2\text{s}^{-1}$ at 373 K , the relation yields $x_D = 0.014 \text{ cm}$. As shown in Fig. 2, this length is roughly coincident with the range of concentration reduction $x = 0.02 \text{ cm}$ in the wall of the plasma vacuum vessel after the baking for 5 days. Since the wall thickness of the plasma vacuum vessel of LHD is $d = 1.5 \text{ cm}$, the range of concentration reduction corresponds to 1 % of the total thickness of the wall.

The outgassing model based on RLM is described and is applied to simulate the hydrogen outgassing rate in the plasma vacuum vessel of LHD. It is shown from the simulation that when the plasma vacuum vessel is degassed by the baking at 100°C , the hydrogen content near surface region of the wall of the plasma vacuum vessel is reduced by about one order of magnitude. For the best fitting of outgassing rates between the calculation and the experiment, it is necessary to select suitably numerical values of recombination coefficient K_r and initial hydrogen concentration u_0 which are used in the calculation model.

References

- [1] B. C. Morre, J. Vac. Sci. Technol. A19, 228 (2001).
- [2] K. Akaishi, M. Nakasuga and Y. Funato, to be published in J. Vac. Sci.

Technol. A 20, No. 3 (2002).

[3] R. A. Langley, J. Nucl. Mater. 128-129, 622 (1984).

[4] V. Nemanic and J. Setina, J. Vac. Sci . Technol. A17, 1040 (1999).

[5] M. A. Pick and K. Sonnenberg, J. Nucl. Mater. 131, 208 (1985).

Figure captions:

Figure 1: (a) The surface concentration $u(0,t)$ and (b) the outgassing rate $2q$ ($= D\partial u / \partial x$) of the plasma vacuum vessel as a function of pumping time.

Figure 2: The hydrogen concentration as a function of position x in the wall of the plasma vacuum vessel at different pumping times.

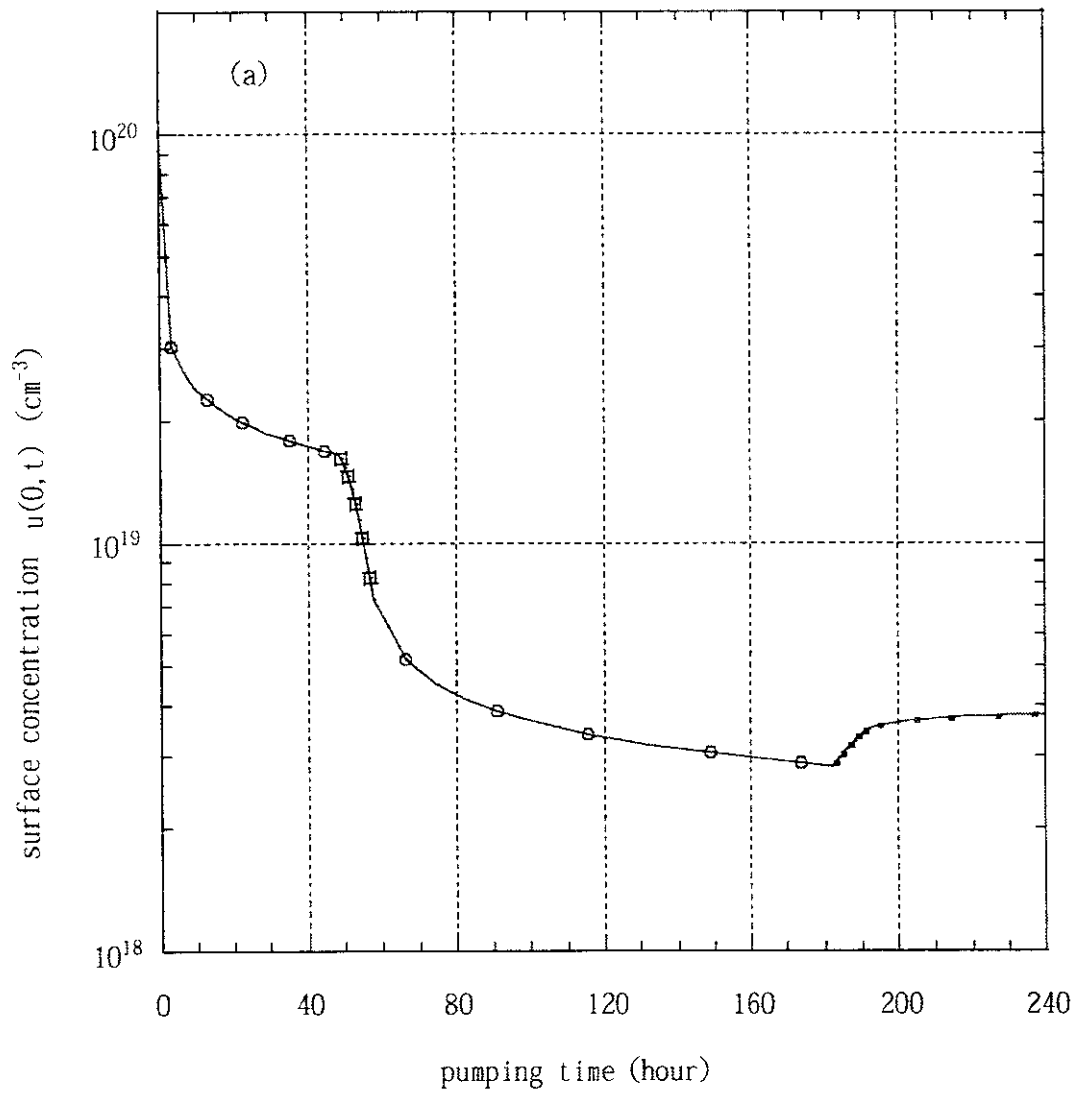


Fig. 1(a)

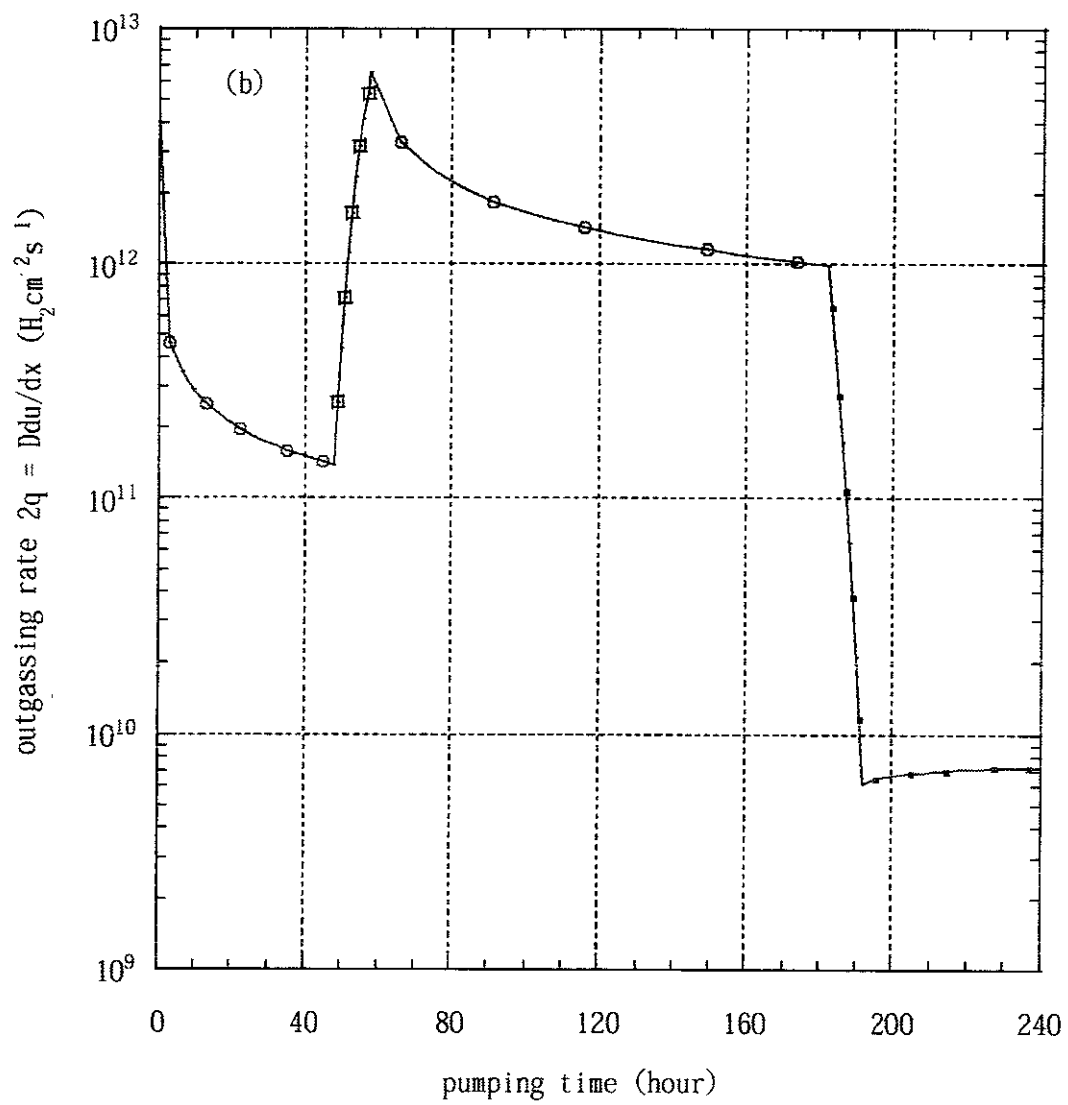


Fig. 1(b)

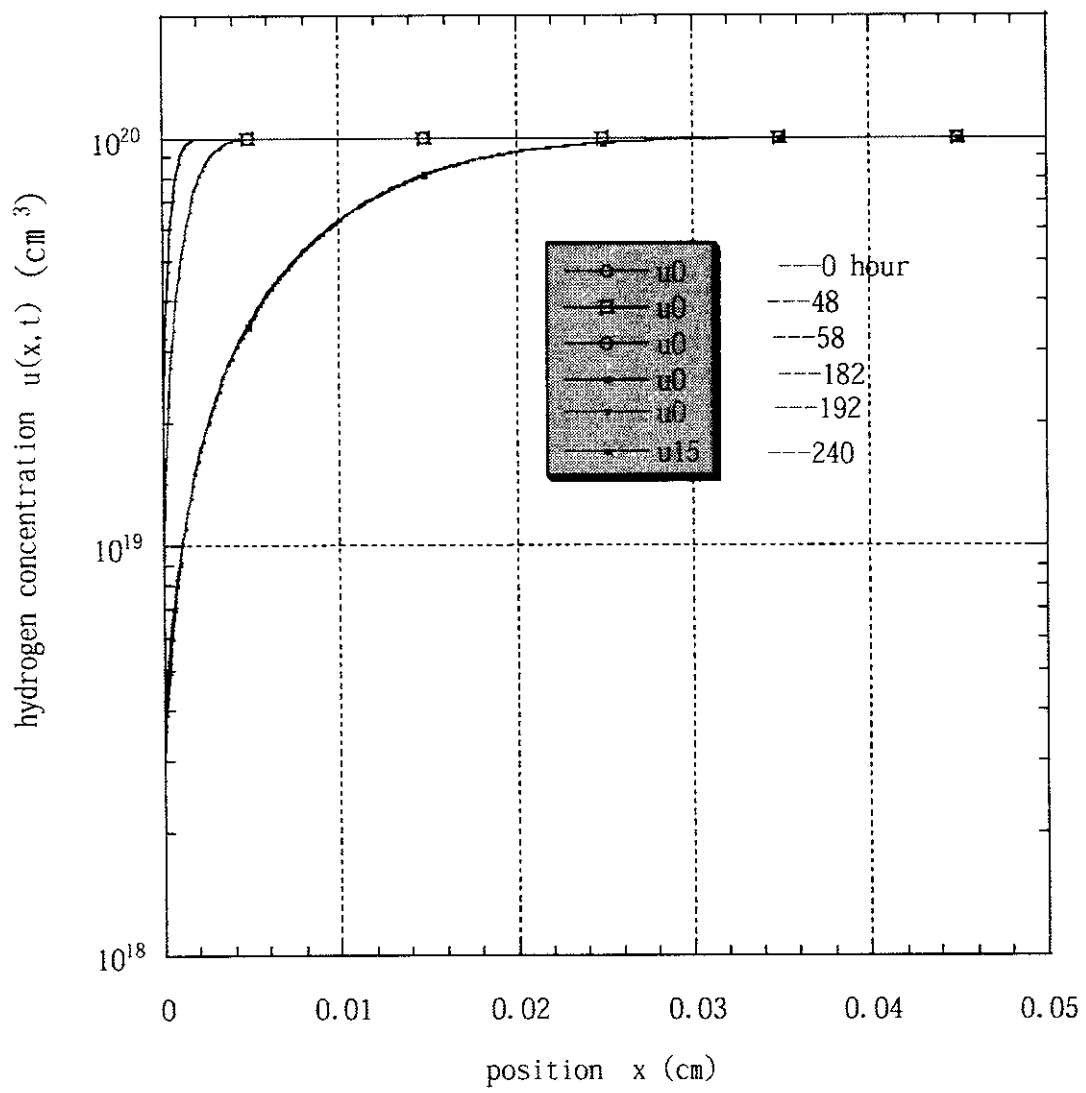


Fig. 2

Recent Issues of NIFS Series

- NIFS-706 M Tanaka and A Yu Grosberg
Electrophoresis of Charge Inverted Macroion Complex Molecular Dynamics Study
July 2001
- NIFS-707 T-H Watanabe, H Sugama and T Sato
A Nondissipative Simulation Method for the Drift Kinetic Equation
July 2001
- NIFS-708 N Ishihara and S Kida
Dynamo Mechanism in a Rotating Spherical Shell: Competition between Magnetic Field and Convection Vortices
July 2001
- NIFS-709 LHD Experimental Group
Contributions to 28th European Physical Society Conference on Controlled Fusion and Plasma Physics (Madeira Tecnopolo, Funchal, Portugal, 18-22 June 2001) from LHD Experiment
July 2001
- NIFS-710 V Yu Sergeev, R K Janev, M J Rakovic, S Zou, N Tamura, K V Khlopenkov and S. Sudo
Optimization of the Visible CXRS Measurements of TESPEL Diagnostics in LHD
Aug 2001
- NIFS-711 M Bacal, M. Nishiura, M. Sasao, M Wada, M Hamabe and H Yamaoka
Effect of Argon Additive in Negative Hydrogen Ion Sources
Aug 2001
- NIFS-712 K Saito, R Kumazawa, T Mutoh, T. Seki, T Watari, T. Yamamoto, Y Torii, N. Takeuchi, C. Zhang, Y. Zhao, A. Fukuyama, F. Shimpou, G. Nomura, M. Yokota, A. Kato, M. Sasao, M. Isobe, A V Krasilnikov, T Ozaki, M. Osakabe, K. Narihara, Y. Nagayama, S. Inagaki, K. Itoh, T. Ido, S. Morita, K. Ohkubo, M. Sato, S. Kubo, T. Shimozuma, H. Ideri, Y. Yoshimura, T. Notake, O. Kaneko, Y. Takeiri, Y. Oka, K. Tsumori, K. Ikeda, A. Komori, H. Yamada, H. Funaba, K. Y. Watanabe, S. Sakakibara, R. Sakamoto, J. Miyazawa, K. Tanaka, B.J. Peterson, N. Ashikawa, S. Murakami, T. Minami, M. Shoji, S. Ohdachi, S. Yamamoto, H. Suzuki, K. Kawahata, M. Emoto, H. Nakanishi, N. Inoue, N. Ohyabu, Y. Nakamura, S. Masuzaki, S. Muto, K. Sato, T. Morigaki, M. Yokoyama, T. Watanabe, M. Goto, I. Yamada, K. Ida, T. Tokuzawa, N. Noda, K. Toi, S. Yamaguchi, K. Akaishi, A. Sagara, K. Nishimura, K. Yamazaki, S. Sudo, Y. Hamada, O. Motojima, M. Fujiwara
A Study of High-Energy Ions Produced by ICRF Heating in LHD
Sep 2001
- NIFS-713 Y. Matsumoto, S-I Oikawa and T. Watanabe
Field Line and Particle Orbit Analysis in the Periphery of the Large Helical Device
Sep. 2001
- NIFS-714 S. Toda, M. Kawasaki, N. Kasuya, K. Itoh, Y. Takase, A. Furuya, M. Yagi and S. -I. Itoh
Contributions to the 8th IAEA Technical Committee Meeting on H-Mode Physics and Transport Barriers (5-7 September 2001, Toki, Japan)
Oct. 2001
- NIFS-715 A. Maluckov, N. Nakajima, M. Okamoto, S. Murakami and R. Kanno
Statistical Properties of the Particle Radial Diffusion in a Radially Bounded Irregular Magnetic Field
Oct. 2001
- NIFS-716 Boris V. Kuteev
Kinetic Depletion Model for Pellet Ablation
Nov 2001
- NIFS-717 Boris V. Kuteev and Lev D. Tsensin
Analytical Model of Neutral Gas Shielding for Hydrogen Pellet Ablation
Nov. 2001
- NIFS-718 Boris V. Kuteev
Interaction of Cover and Target with Xenon Gas in the IFE-Reaction Chamber
Nov. 2001
- NIFS-719 A. Yoshizawa, N. Yokoi, S-I Itoh and K. Itoh
Mean-Field Theory and Self-Consistent Dynamo Modeling
Dec. 2001
- NIFS-720 V N. Tsytovich and K. Watanabe
Universal Instability of Dust Ion-Sound Waves and Dust-Acoustic Waves
Jan. 2002
- NIFS-721 V N. Tsytovich
Collective Plasma Corrections to Thermonuclear Reactions Rates in Dense Plasmas
Jan. 2002
- NIFS-722 S. Toda and K. Itoh
Phase Diagram of Structure of Radial Electric Field in Helical Plasmas
Jan 2002
- NIFS-723 V.D. Pustovitov
Ideal and Conventional Feedback Systems for RWM Suppression
Jan. 2002
- NIFS-724 T. Watanabe and H. Hojo
The Marginally Stable Pressure Profile and a Possibility toward High Beta Plasma Confinement in LHD
Feb 2002
- NIFS-725 S -I Itoh, K. Itoh, M. Yagi, M. Kawasaki and A. Kitazawa
Transition in Multiple-scale lengths Turbulence in Plasmas
Feb. 2002
- NIFS-726 S -I Itoh, A. Kitazawa, M. Yagi and K. Itoh
Bifurcation and Phase Diagram of Turbulence Constituted from Three Different Scale-length Modes
Apr 2002
- NIFS-727 M. Nagata
Preliminary Experiment on the Negative Magneto-Resistance Effect in a Weakly Ionized Plasma
Apr. 2002
- NIFS-728 K. Akaishi and M. Nakasuga
Calculation of Hydrogen Outgassing Rate of LHD by Recombination Limited Model
Apr. 2002